



Att'y. Dkt. AMAT/5699/CMP/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Chen, et al.

Serial No.: 10/038,066

Confirmation No.: 5741

Filed: January 3, 2002

For: Planarization of Substrates  
Using Electrochemical  
Mechanical Polishing

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

05/06/2003 FFANAEIA 00000001 200782 10038066

01 FC:1806

180.00 CH

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

Group Art Unit: 2842

Examiner:

1742  
WILKINS  
Hakim

TO 2600 MAIL ROOM

28128  
PATENT  
SAD  
#5  
5.14.03  
RECEIVED  
MAY-5 2003

CERTIFICATE OF MAILING  
37 CFR 1.8

I hereby certify that this correspondence is being deposited on April 30, 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231.

04/30/03  
Date

Signature


RECEIVED

MAY 12 2003

GROUP 1700

If the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/AMAT/5699/BKH.

Respectfully submitted,



---

Brian K. Hrna  
Registration No. 41,852  
MOSER, PATTERSON & SHERIDAN, L.L.P.  
3040 Post Oak Blvd., Suite 1500  
Houston, TX 77056  
Telephone: (713) 623-4844  
Facsimile: (713) 623-4846  
Attorney for Applicant(s)